

# ERIBS: Towards better heavy ion beam services

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On behalf of the ERIBS collaboration



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## ERIBS partners



ATOMKI  
CNRS-IPHC  
INFN-LNL  
INFN-LNS  
GANIL  
GSI-FAIR  
JYFL  
UMCG-PARTREC  
CNRS-LPSC (associate partner)



## ERIBS tasks



**Objectives of ERIBS are to improve:**

Task 1: Ion beam variety and production efficiency (Leader: Alessio Galata, INFN-LNL)

Task 2: Short and long-term beam stability (Leader: Rob Kremers, PARTREC)

# Task 1

ION BEAM VARIETY AND PRODUCTION EFFICIENCY



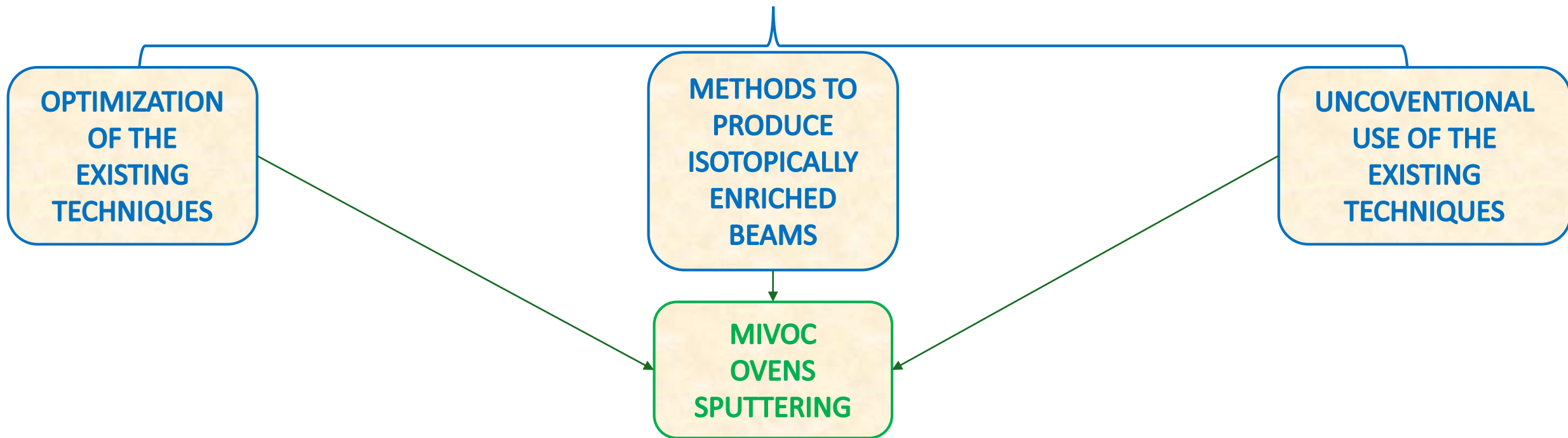
INCREASE/IMPROVE BEAMS AVAILABLE FOR THE USERS

OPTIMIZATION  
OF THE  
EXISTING  
TECHNIQUES

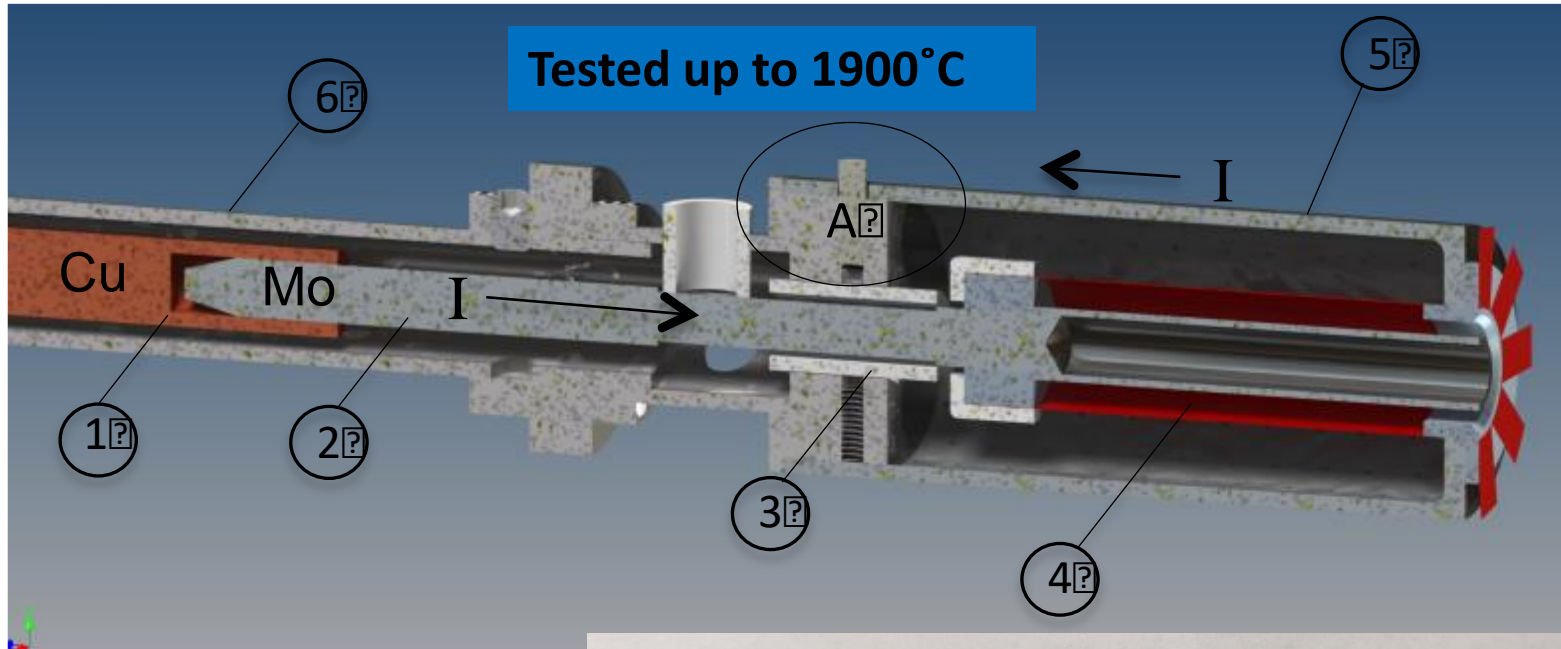
METHODS TO  
PRODUCE  
ISOTOPICALLY  
ENRICHED  
BEAMS

UNCONVENTIONAL  
USE OF THE  
EXISTING  
TECHNIQUES

MIVOC  
OVENS  
SPUTTERING



# Task1: High temperature oven



History: The assembly of the heater foil was challenging → unreliable solution

Due to challenges, this oven approach was abandoned at JYFL for almost 10 years

GANIL team continued the development of the foil oven concept

- 1) copper rod,
  - 2) Mo support structure,
  - 3)  $Al_2O_3$  insulator,
  - 4) Ta foil (20  $\mu m$  in thickness),
  - 5) outer Mo oven structure for return current,
  - 6) SS tube for return current.
- A) locking/connection system (bajonet)



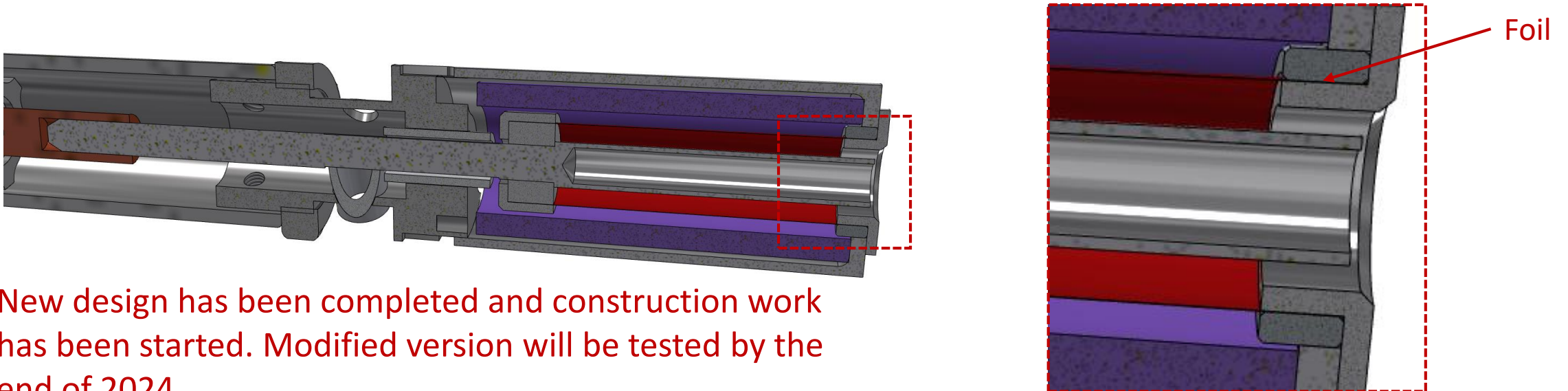
# High temperature oven knowledge transfer between GANIL and JYFL



Visit of JYFL team members to GANIL in May 2024:

- The GANIL high temperature oven would require strong modifications to the JYFL foil oven and to the injection of the JYFL 14 GHz ECRIS.
- we decided to revisit the design of the JYFL foil oven → a **novel new solution** was found

→ **New high temperature oven design for EURO-LABS laboratories**



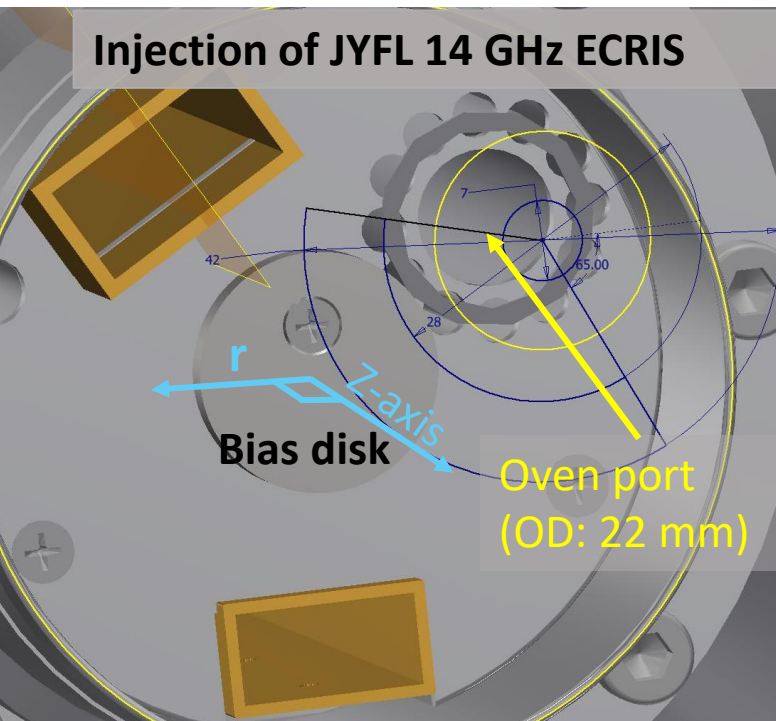
New design has been completed and construction work has been started. Modified version will be tested by the end of 2024.



# Axial sputtering for metal ion beams

Axial sputtering is not available with the European ECR ion sources

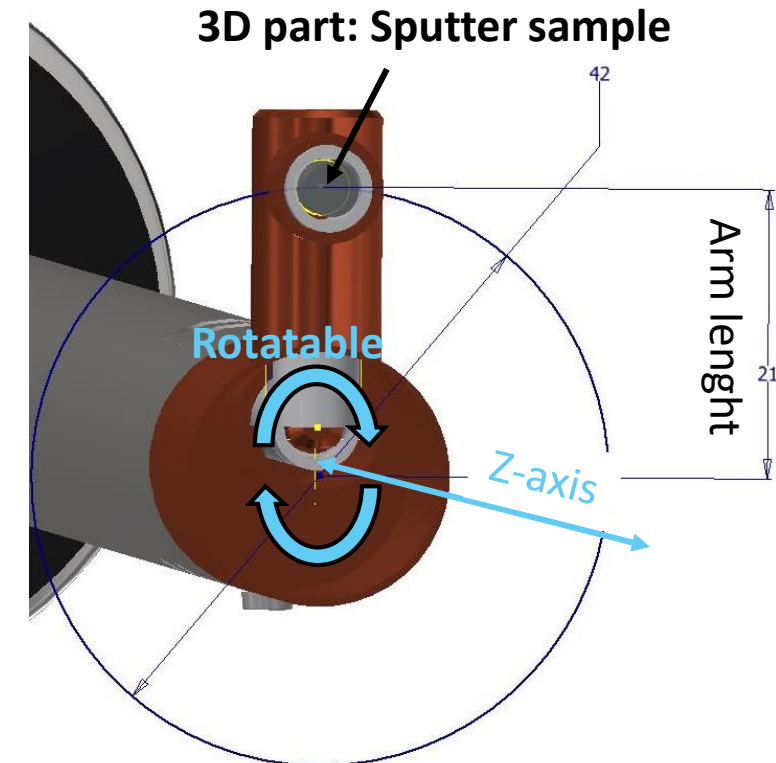
- In ERIBS: development work for ON- and OFF- axis sputtering (**INFN-LNL/JYFL collaboration**)
- Optimum geometry for the sputter sample will be *simulated* by the INFN-LNL team



## To find an optimum sample position in 3D

- Movable sample along z-axis
- Rotatable
- Different arm lengths will be tested

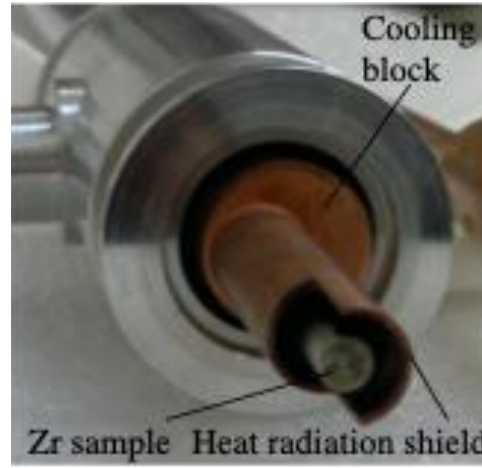
→ Determination of optimum sputtering conditions for maximum beam performance



# First off-axis sputter experiments

First 1D experiments along the axis of plasma chamber: (without the “3D part”)

JYFL 14 GHz ECRIS



- Intensity increased vigorously when the sample was moved along the axis
- Very promising intensities for highly charged Zr ( $> 5 \mu\text{A}$  for  $\text{Zr}^{18+}$ )

More makes more → let's move sample further:

- More beam but...melting of copper holder
- New design has been completed
- **Studies will be continued as soon as all parts are machined**

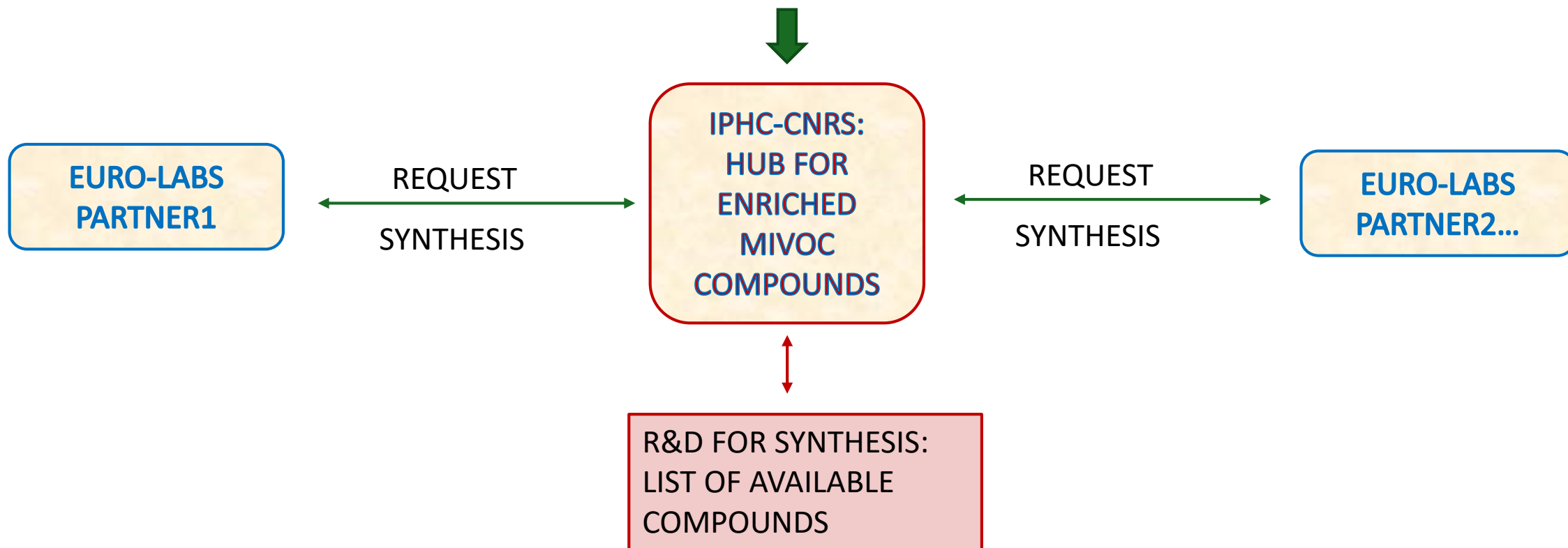




# Hub for enriched MIVOC beams



ENRICHED MIVOC COMPOUNDS WOULD IMPROVE BEAM INTENSITIES



For example: compounds for  $^{54}\text{Cr}$ ,  $^{64}\text{Ni}$  (JYFL) and  $^{50}\text{Cr}$  (GANIL) ion beams have been synthesized by IPHC for scientific programs of EURO-LABS

# Transfer of MIVOC technology

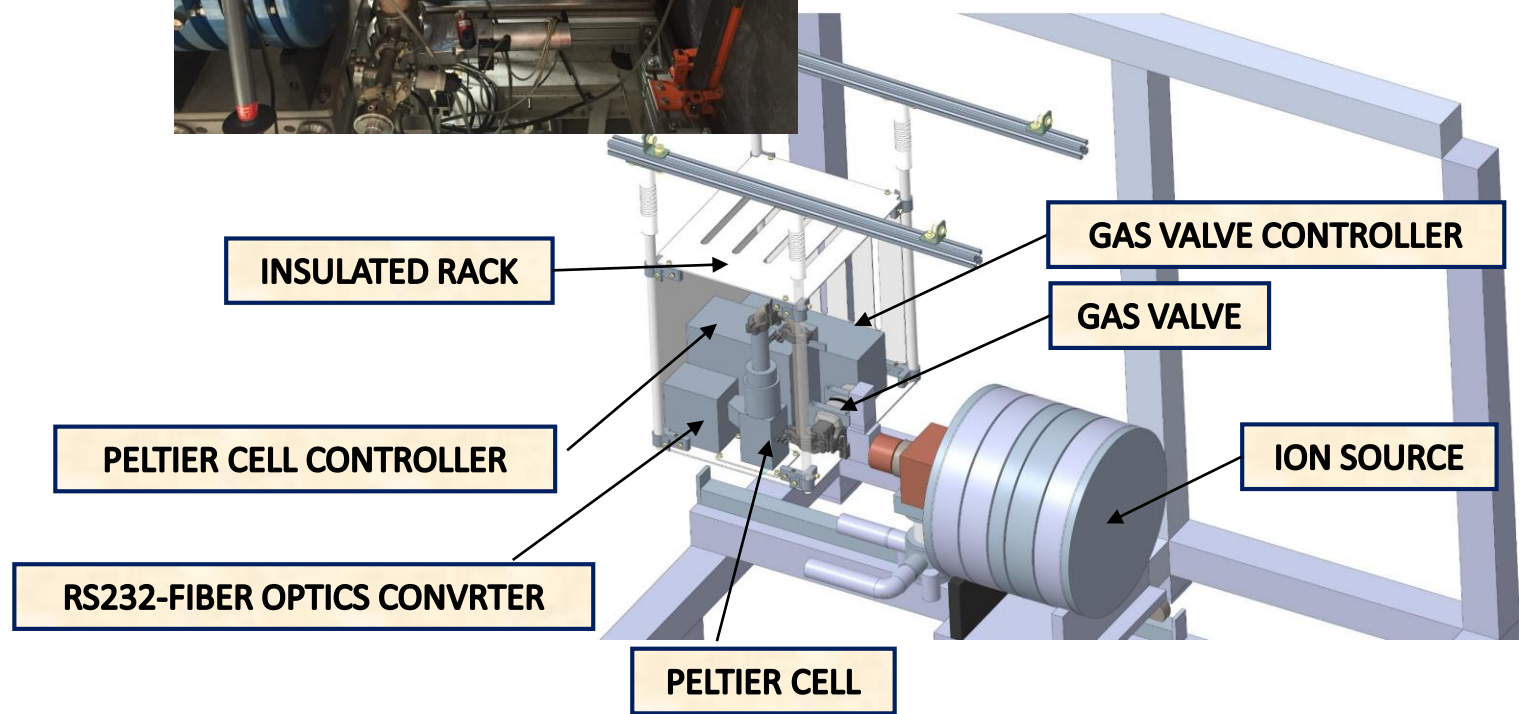
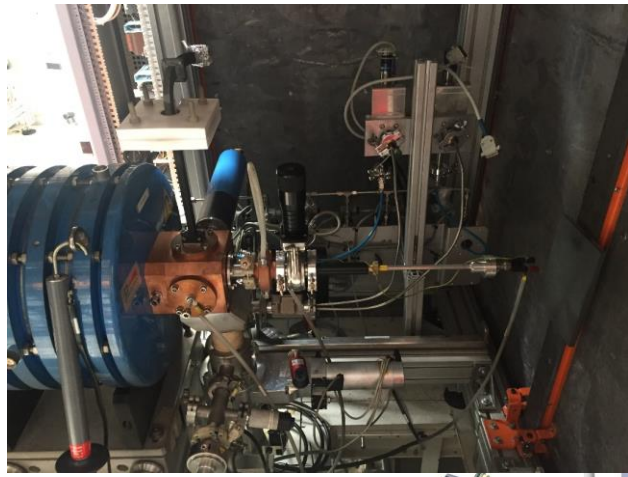
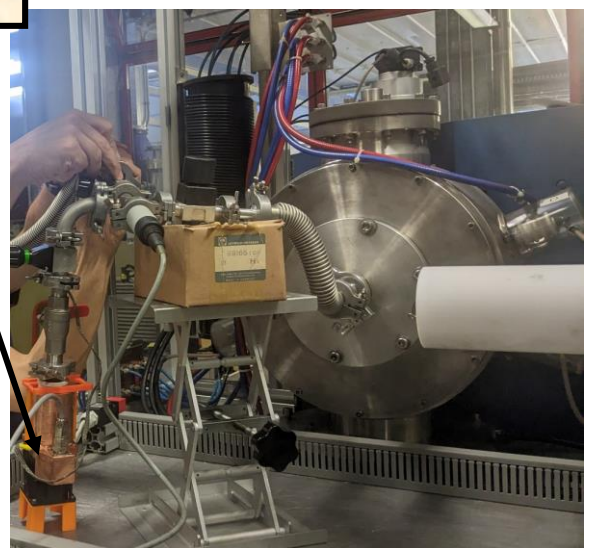
## LNL TRAINING ON MIVOC BY IPHC team

## IMPLEMENTATION OF MIVOC @ LNL



**PELTIER CELL CONTROLLER**

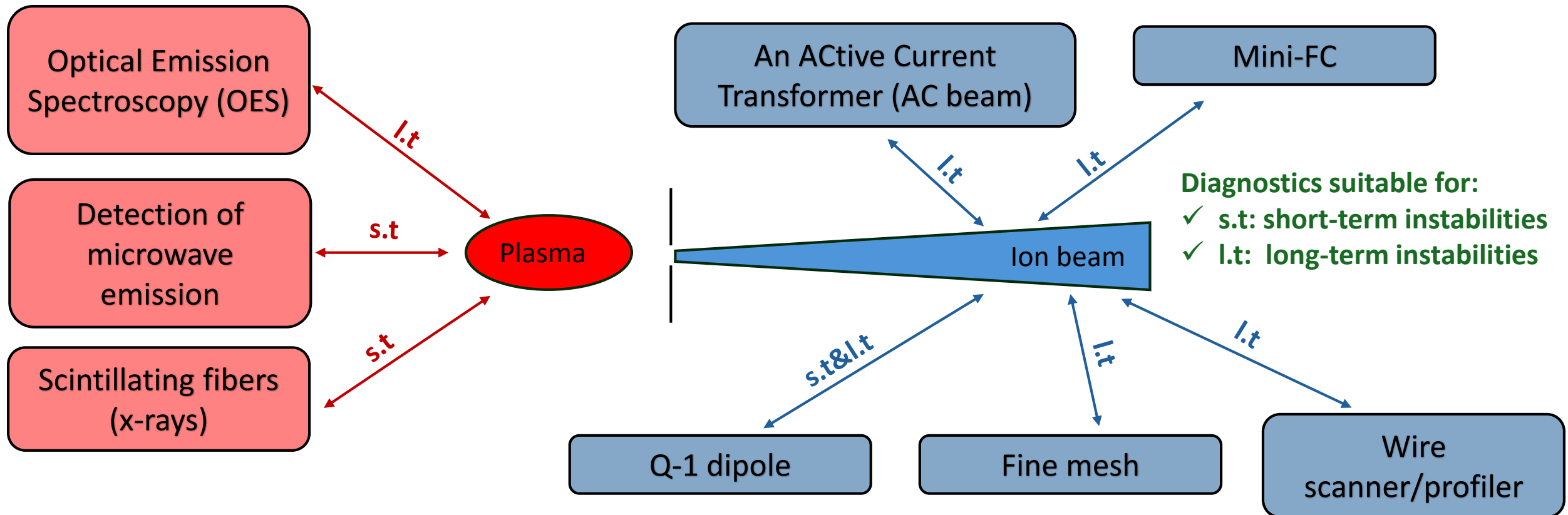
**PELTIER CELL**



## Task2

**Objective:** development work to improve the (**low cost and robust**) short- and long-term beam stability and to keep the beam intensity within preset values.

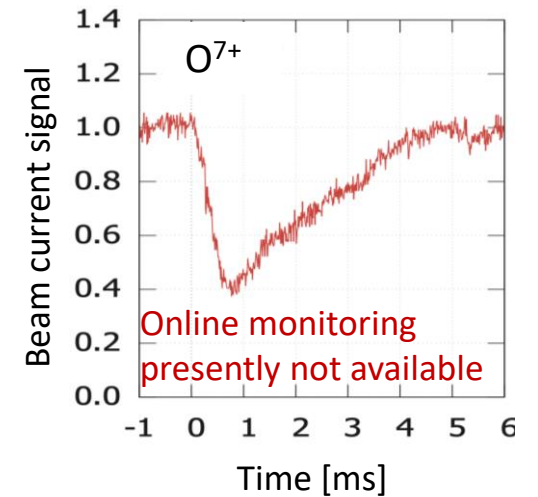
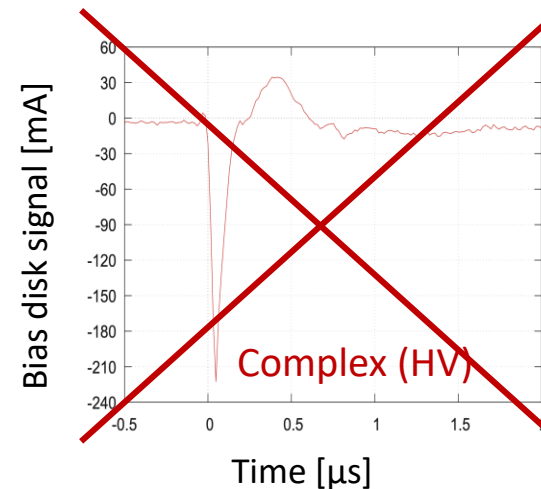
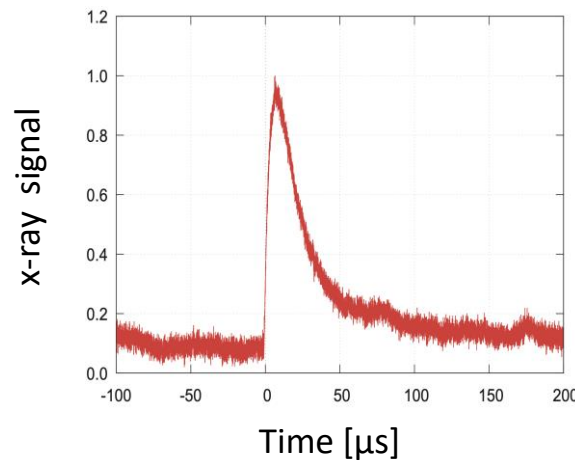
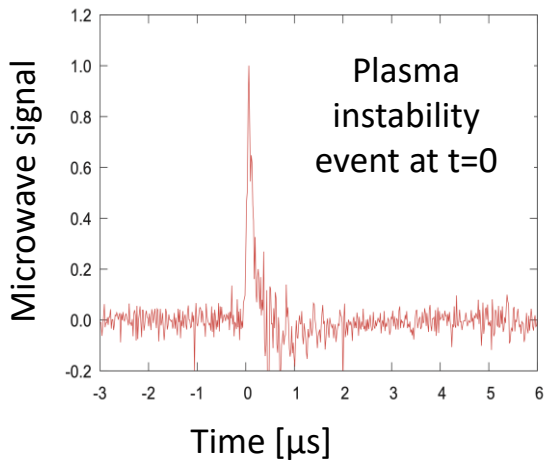
Following techniques/approaches have been included for the task:



# Online monitoring: short-term instabilities

- Plasma instability decreases beam intensity. This effect increases with charge state  $q$
- Sputters plasma chamber  $\rightarrow$  erosion of plasma chamber, beam contamination
- Ion beam inherits the plasma instabilities

Possible signals for monitoring (s.t) : microwave emission, x-rays, bias disk current, FC current



Possible diagnostics for online monitoring

Detection of microwave emission

Scintillating fibers

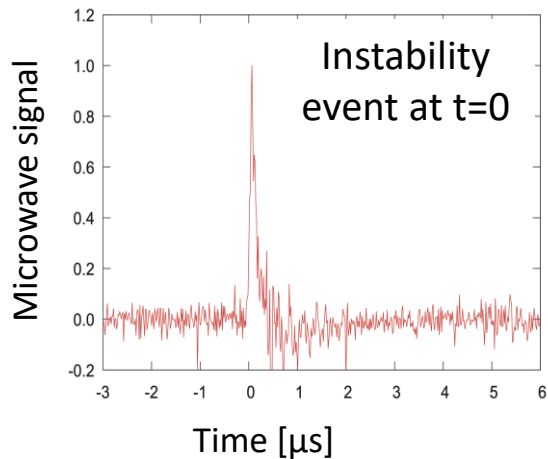
Q-1 dipole



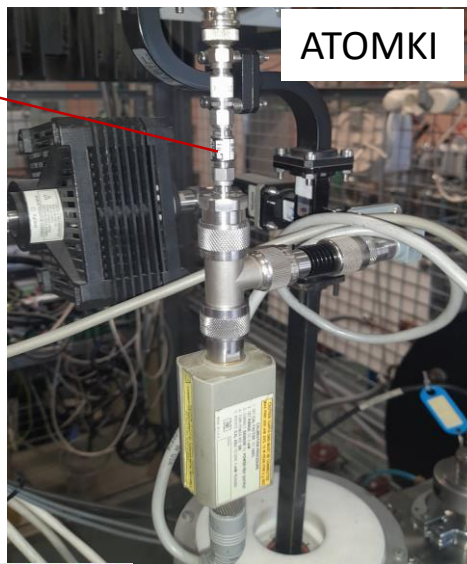
# Low cost monitoring of plasma instabilities: **ATOMKI+INFN-LNS**



## Microwave detection

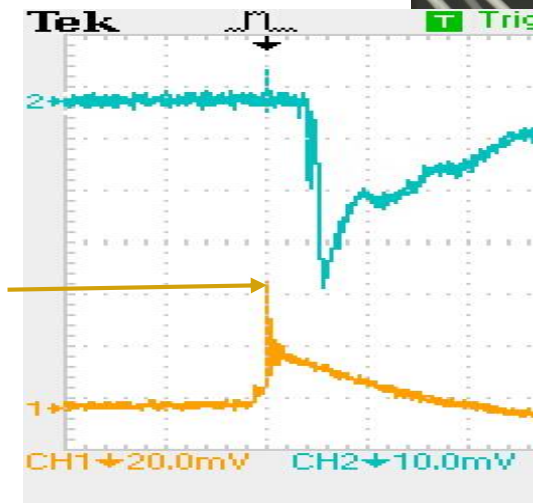


RF power diode for plasma emitted microwaves



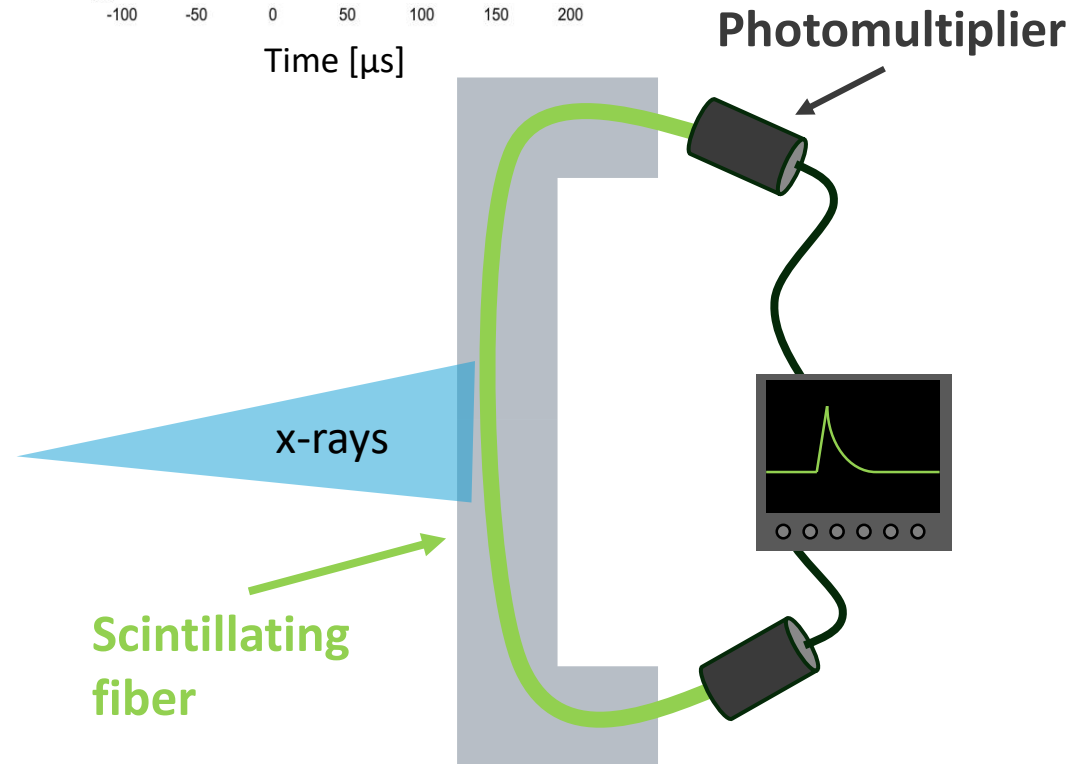
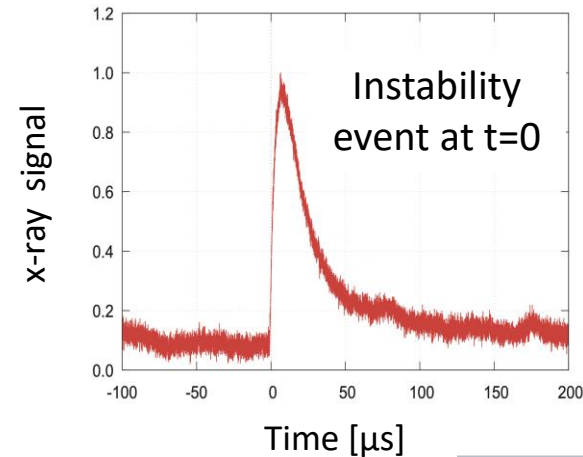
Highly charged ion beam current

RF emission peak caused by kinetic instability



Good correlation between beam current and RF emission!

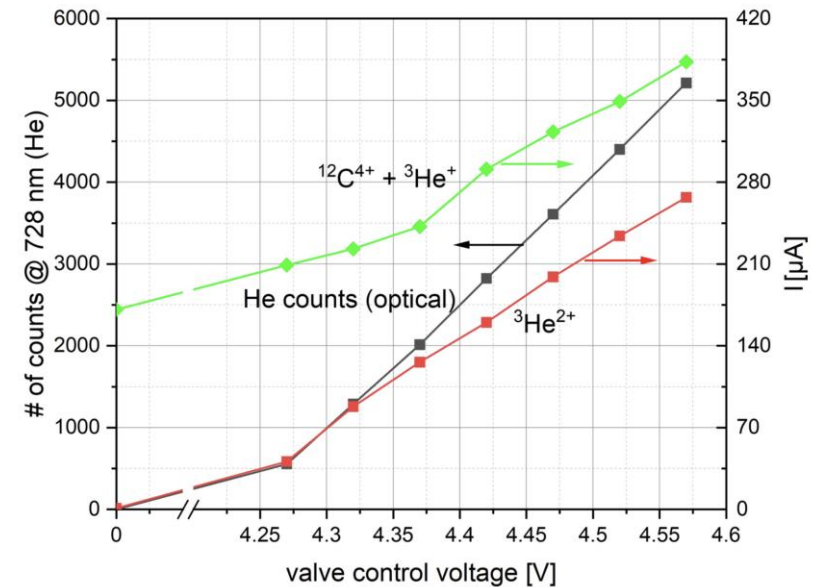
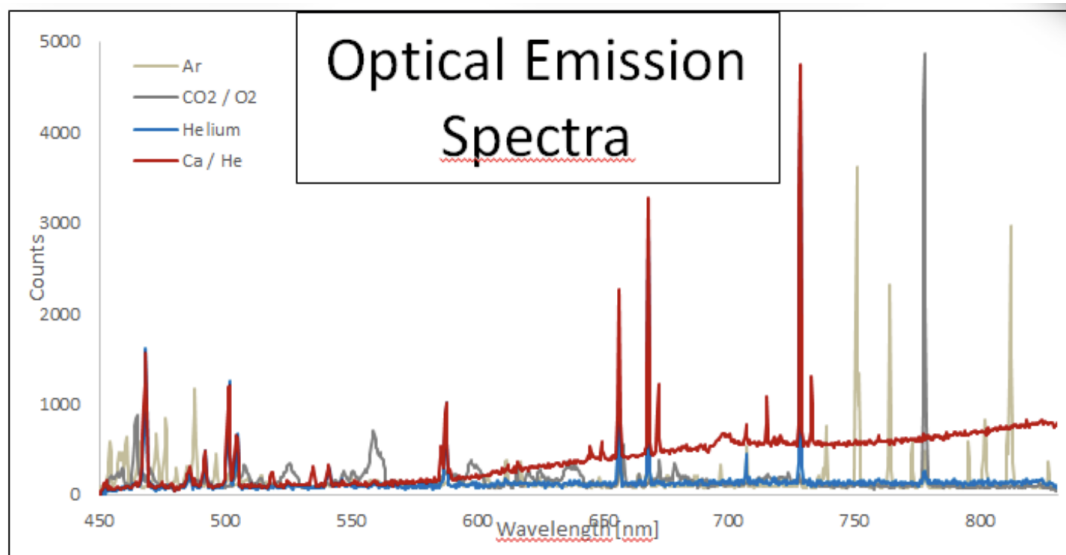
## X-ray detection





- At GSI, it has been demonstrated that optical emission spectroscopy (OES) is suitable for metallic ion beam monitoring and operation
- Feasibility study for long-term plasma monitoring for noble gases (Ar, Kr, etc.)

Ca with oven

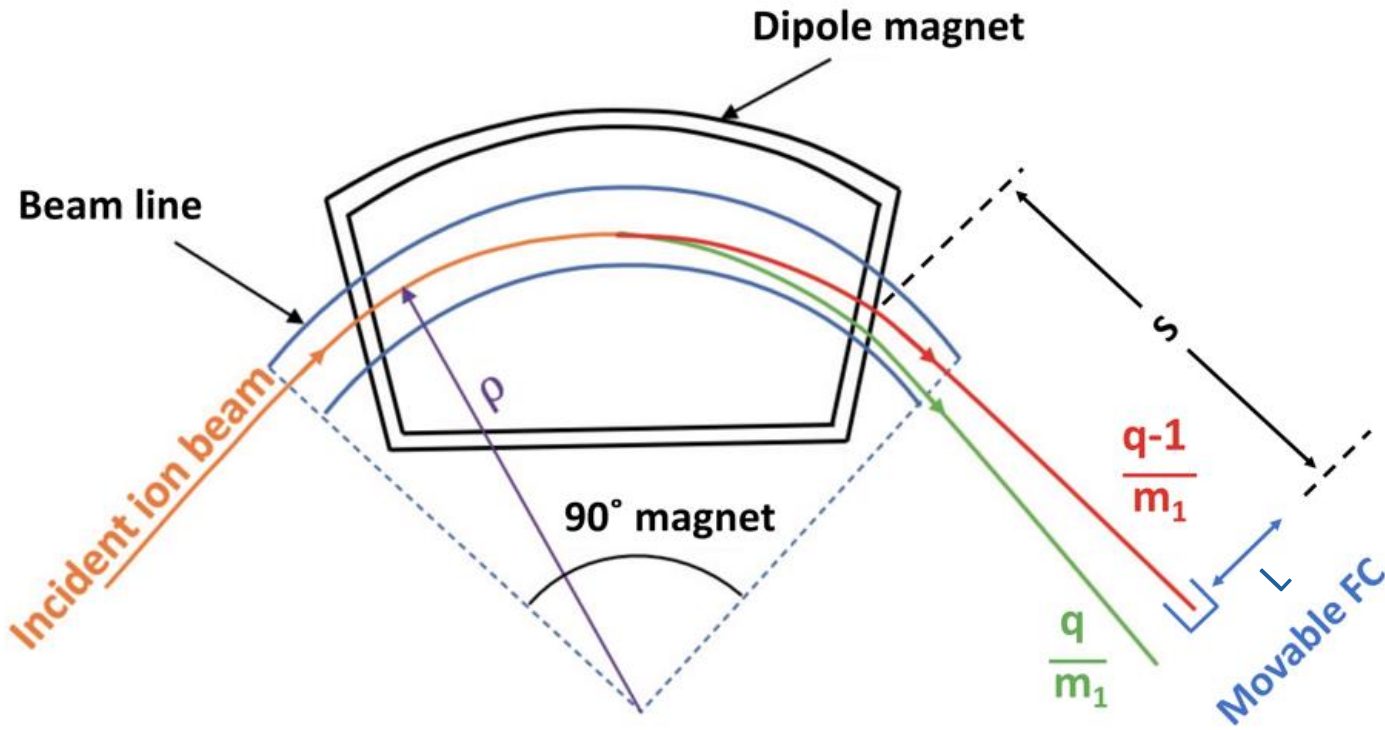


F. Maimone et al 2024  
 J. Phys.: Conf. Ser.  
 2743 012048

- Spectral peaks → elemental identification, and monitoring of intensity
- Infrared spectrum → oven temperature

# Q-1dipole: online beam monitoring

Allows online monitoring of q-1 beam while beam of interest is delivered to cyclotron (charge state q).  
 The diagnostic is capable of monitoring both short- and long-term beam stabilities



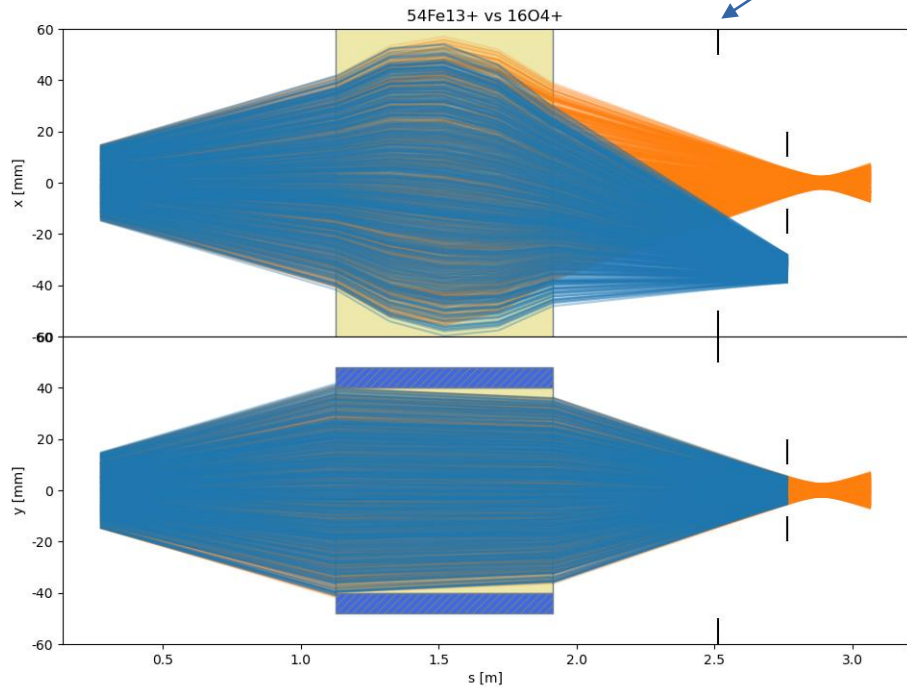
## Define:

- Location (S) of movable FC along beam propagation for adequate q/m resolution
- Movement range (L) of q-1 FC

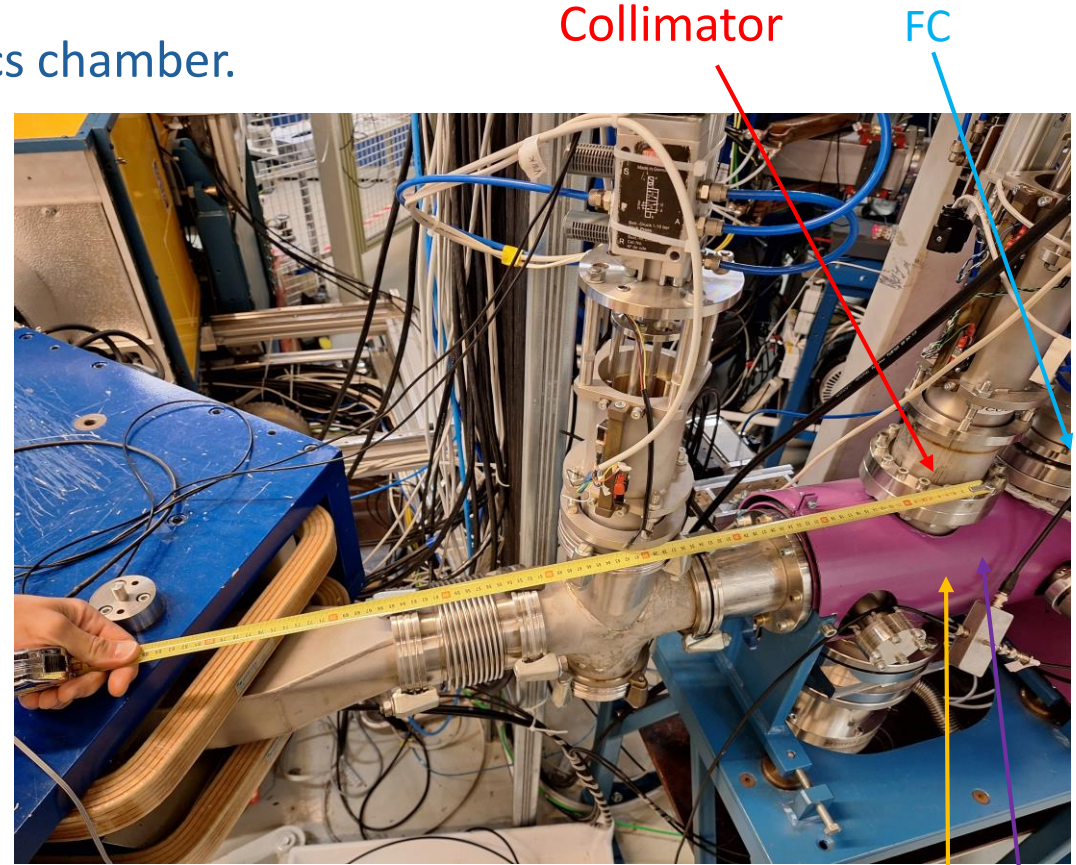
# Location of q-1 diagnostics



Beam species are not separated before start of diagnostics chamber.



Same way: movement L of q-1 FC was defined



Approximate location S for q-1 FC

Diagnostics chamber

**Technical design work has been started**

## Feedback to maintain stable conditions



### Objective for the response system (**leader PARTREC**):

- A. Alarm to the operator: unstable conditions/the preset intensity limit has been exceeded
- B. System gives instructions to restore the stable conditions/requested beam intensity

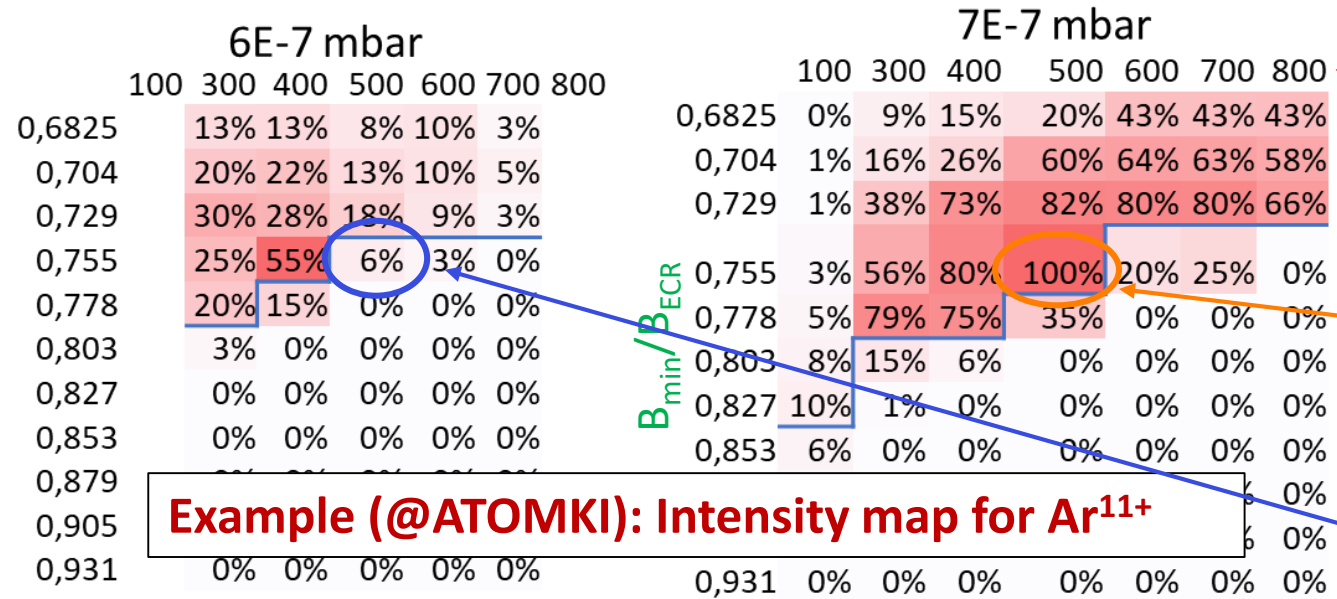
### In order to accomplish this:

- sample the beam current to calculate the average current and standard deviation
- define the most relevant operation parameters (**multidimensional map**) and track them to maintain the stable operation condition



# Example: Multidimensional map for response system

Power-Bmin/Beccr-Maps



**Example (@ATOMKI): Intensity map for Ar<sup>11+</sup>**

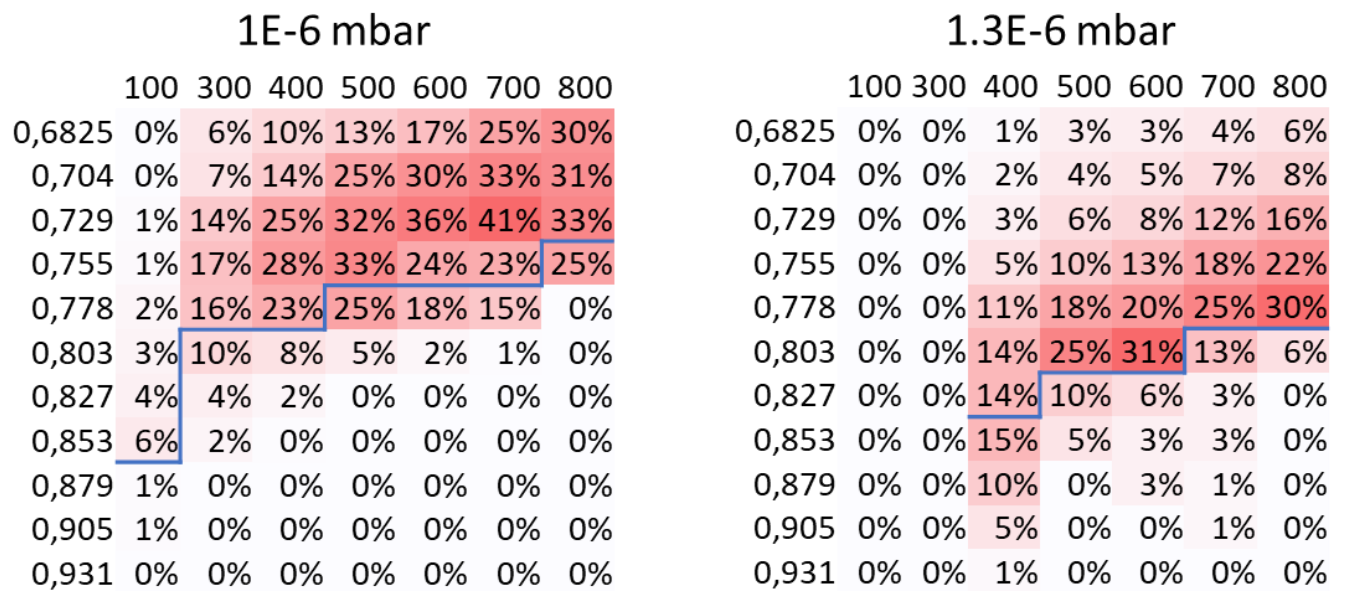
Microwave power

Instability threshold

Optimum operation point for Ar<sup>11+</sup>

Pressure decreases →  
New operation point

This is unstable operation point! Feedback system has to guide to restore the stable condition



Challenging and complex, multidimensional problem